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Docket No. EHAR0010
US App. No. 09/856,402

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : TERUYUKI NAKANO et al.

Application No. : 09/856,402

Filed : October,12,2001

For : POLISHING MACHINE FOR PERIPHERAL
EDGE OF SEMICONDUCTOR

Examiner : MACARTHUR, SYLVIA

Attorney Docket No. : EHAR0010

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated November 4, 2004 and in view of the telephone interview of January 21, 2005, Applicant submits herewith the following amendments and remarks together with a Request for Continued Examination (RCE) .